



Attorney Docket No. 0756-7176

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Patent Application of:

Koji DAIRIKI

Serial No. 10/625,737

Filed: July 24, 2003

For: SEMICONDUCTOR DEVICE

MANUFACTURING METHOD, HEAT

TREATMENT APPRATUS AND

HEAT TREATMENT METHOD

) Group Art Unit: 2822

) Examiner: Maria F. Guerrero

) CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on March 29, 2006.

Adile M. Stampur

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated December 29, 2005, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.